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February 4, 2004

Office of Initial Patent Examination's Filing Receipt Corrections
Fax No. 703- 746-9195

Re: REQUEST FOR CORRECTED FILING RECEIPT

Inventor(s) : Keun-Deok Park et al.
Assignor(s) : Samsung Electronics Co., Ltd.
Title : COLLOIDAL SILICA COMPOSITION AND
PRODUCTION METHOD THEREOF
Serial No. : 10/607,156
Filed : June 26, 2003
Docket No. : 5000-1-321

Dear Sir:

Applicant hereby request that a corrected Formal Filing Receipt be issued to correct the four applicant's residency.

Please correct the four applicant's residency. A Response to Notice of Informal Application was filed on September 25, 2003 along with the Executed Declaration, copies attached.

A copy of the filing receipt with the requested correction is enclosed.

Applicants accordingly request that the records of the U.S. Patent and Trademark Office be corrected to reflect the four applicant's residency and that a corrected Formal Filing Receipt be issued.

Respectfully submitted,

Steve Cha
Attorney for Applicant(s)
Registration No. 44,069SC/lc
Enclosur s

Serial No. 10/007,156 Docket No. 50001-321 Div. _____
Title COLLOIDAL SILICA COMPOSITION AND
In the Application of Reun-De K. Buckel et al.
the following papers have been received by the Patent and Trademark Office, as
indicated by the date stamped hereon:

- | | | |
|--|---|-----------------------------------|
| <input type="checkbox"/> Application For Patent | <input type="checkbox"/> Amendment | <input type="checkbox"/> Response |
| _____ pages of spec., claims & abs. | <input type="checkbox"/> Extension of Time | |
| <input checked="" type="checkbox"/> Declaration <i>Executed</i> | <input type="checkbox"/> Issue Fee | |
| <input type="checkbox"/> Drawings _____ Sheet(s) P E | <input type="checkbox"/> Maintenance Fee | |
| <input type="checkbox"/> Assignment | <input type="checkbox"/> Appln. TM Registration | |
| <input type="checkbox"/> Priority document | <input type="checkbox"/> 8 & 15 Declaration | |
| <input type="checkbox"/> Power of Attorney | <input type="checkbox"/> Renewal Application | |
| <input type="checkbox"/> Check for S _____ | <input type="checkbox"/> Notice of Appeal | |
| <input checked="" type="checkbox"/> <i>Response to Notice of</i> | <input type="checkbox"/> Brief | <input type="checkbox"/> Petition |
| <i>Final Application</i> | | |

**DOCKET**

OCT 8 2003

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CONTINENTAL PLAZA

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Patent, Trademark
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September 25, 2003

MAIL STOP MISSING PARTS
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

Re: U.S. Patent Application
Applicant(s) : Keun-Deok Park et al.
Serial No. : 10/607,156
Filed : June 26, 2003
Title : COLLOIDAL SILICA COMPOSITION AND
PRODUCTION METHOD THEREOF
Docket No. : 5000-1-321

CERTIFICATE OF MAILING UNDER 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to MS MISSING PARTS, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA. 22313-1450 on September 25, 2003.

STEVE CHA, Reg. No. 44,069

(Name of Registered Representative)


(Signature and Date) 9/25/03RESPONSE TO NOTICE OF INFORMAL APPLICATION

Sir

Responsive to the Notice of Informal Application dated, September 22, 2003, copy enclosed, Applicants submit herewith the following:

1. A combined Declaration and Power of Attorney in two (2) counterparts making reference to the above-identified application, and in compliance with 37 CFR 1.63.

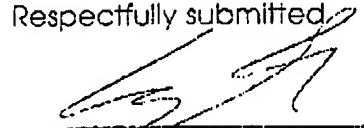
Response To Notice of Informal Application:
September 25, 2003
Page 2

Docket No. 5000-1-321

A correct Filing Receipt reflecting the above and attached information is requested.

Applicants hereby authorize that any charges that relate to the filing and processing of the present Application in accordance with 37 CFR 1.63 may be charged to Deposit Account No. 502-470.

Respectfully submitted,



Steve Cha
Attorney for Applicant(s)
Registration No. 44,069

SC/lc
Enclosure

CHA & REITER



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
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P.O. Box 1450
Alexandria, Virginia 22313-1450
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/607,156	06/26/2003	2874	750	5000-1-321		14	3

CONFIRMATION NO. 5603

33942
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FILING RECEIPT

OC000000010895126

Date Mailed: 09/22/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2002-36289 06/27/2002

If Required, Foreign Filing License Granted: 09/16/2003

Projected Publication Date: 01/01/2004

Non-Publication Request: No

Early Publication Request: No

Title

Colloidal silica composition and production method thereof

SEP 24 2003

Preliminary Class

385

**LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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